



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Toshihiko TSUJI et al.

Group Art Unit: 2881

Application No.: 10/585,001

Examiner: A. SMYTH

Filed: June 29, 2006

Docket No.: 128591

For: AN EXPOSURE APPARATUS AND DEVICE MANUFACTURING METHOD

**AMENDMENT FILED WITH RCE**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the November 4, 2008 Office Action, the statutory period for reply being extended by the attached Petition for Extension of Time, and in view of the attached Request for Continued Examination (RCE), please consider the following:

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**

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